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In re the Application of Park et al

Docket Number: TI-25320

MAY 27 2004

Serial No.: 09/173,129

Art Unit: 2814

Filed: 10/15/1998

Examiner: Peralta, G.

Conf. No.: 1320

OFFICIAL

For: Selective Oxidation for Semiconductor Device Fabrication

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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): Park et al	
RECEIPT DATE & SERIAL NO.: Serial No.: 09/173,129 Filing Date: 10/15/1998	
TITLE OF INVENTION: Selective Oxidation for Semiconductor Device Fabrication	
TI FILE NO.: TI-25320	DEPOSIT ACCT. NO.: 20-0668
FAXED: May 27, 2004 DUE: 4/28/2004 ATTY/SEC'Y: Alan W. Lintel	

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TI-25320

Patent Amendment RECEIVED
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAY 27 2004

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Applicant(s): Park, et al.

Application No.: 09/173,129

Filed: 10/15/1998

Title: Selective Oxidation for Semiconductor
Device Fabrication

Attorney Docket No.: TI-25320

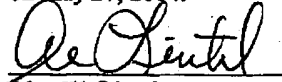
Group Art Unit: 2814

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Tech Grp Fax: Official 703-872-9306

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Alan W. Lintel

May 27, 2004

Date

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RESPONSE UNDER 37 CFR 1.111

Dear Sir:

In response to the Office Action of January 28, 2004, please review this
application in view of the following:

Remarks/Arguments begin on page 2 of this paper.